10th EUV-FEL Workshop



Contribution ID: 4 Type: **not specified**

[Key-note Lecture] Development of Next-Generation Semiconductor Process, Technologies for EUV and BEUV under Japan's "K Program" by JST

Wednesday, 28 January 2026 13:35 (40 minutes)

Presenter: JUNJI YUMOTO (THE UNIVERSITY OF TOKYO)